

Search Notes

Application/Control No.

09/854,463

Examiner

Erick Rekstad

Applicant(s)/Patent under
Reexamination

HANNUKSELA ET AL.

Art Unit

2621

SEARCHED

Class	Subclass	Date	Examiner
375	240.27 240.01 240.13 240.25		ER
386	117		ER
382	232		ER
348	14.01		ER
348	14.02		ER

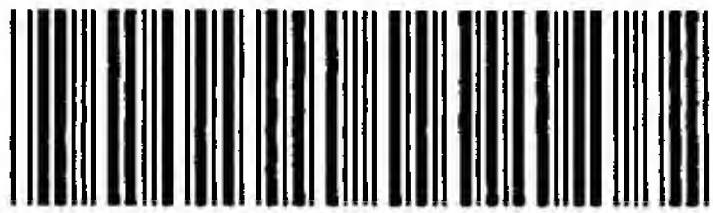
INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
375	240.25	5/27/2005	ER
375	240.27	11/14/2005	ER

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
IEEE: error <and> concealment <and> video	5/27/2005	ER
IEEE, ACM Digital Library, CiteSeer, Optics Information Database search for (h.263 and supplemental enhancement)	11/14/2005	ER
keyword search	7/21/2004	ER
keyword search	5/27/2005	ER
keyword search	11/14/2005	ER
keyword search	9/1/2006	ER
keyword search	12/10/2006	ER
PLUS search	4/20/2007	ER

Search Notes (continued)



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	DATE	EXMR
keyword search	9/14/2007	ER